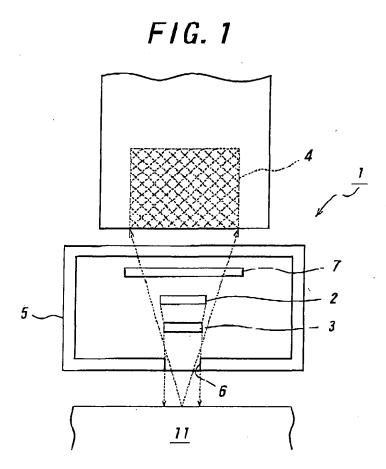
Applicants: Yasuharu SHIRAI and Hideki ARAKI
Title: MATERIAL DEFECT EVALUATION APPARATUS USING POSITRON AND ITS EVALUATION METHOD
Our Docket No.: 782_231





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FIG. 2

